

MS AF
Amendment Under 37 C.F.R. §1.116
Expedited Processing
Examining Group 2815
PATENT
3430-0131P

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

HWANG, Kwang-Jo

CONF.:

5562

SERIAL NO.:

09/648,111

GROUP:

2815

FILED:

August 25, 2000

EXAMINER: BROCK II, P.

FOR:

METHOD OF PATTERNING A METAL LAYER IN A

SEMICONDUCTOR DEVICE

## AMENDMENT UNDER 37 C.F.R. § 1.116

## Box AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 December 20, 2005

Dear Sir:

In response to the final Office Action dated September 20, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes Amendments to the Claims and Remarks.

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